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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/075,193 -
Filing Date February 13, 2002
Inventor Shenlin Chen et al.
Assignee Micron Technology, Inc.
Group Art Unit 2813
Examiner Huynh, Y.
Attorney's Docket No. MI22-1927
Title: Methods of Forming a Capacitor Structure

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References -See Attached Form PTO-1449

The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449, copies of which are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of the referenced art is respectfully requested.

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Respectfully submitted,

Dated:

March 12, 2003

By:

Jennifer J. Taylor
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Reg. No. 48,711

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